



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Masatoshi YASUTAKE et al. :  
Serial No. 10/775,724 : Group Art Unit - 2823  
Filed: February 10, 2004 : Examiner- Quovaunda Jefferson  
For: PREPARATION OF SAMPLE :  
CHIP, METHOD OF OBSERVING :  
WALL SURFACE THEREOF AND :  
SYSTEM THEREFOR : Docket No. S005-5210

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**AMENDMENT AFTER FINAL  
UNDER RULE 116**

S I R:

In response to the Office Action dated June 29, 2006, applicants request reconsideration of their application as follows:

**ADDITIONAL FEES:**

No additional fees are believed required in connection with this amendment; however, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account No. 01-0268.

**MAILING CERTIFICATE ON PAGE 17**

Please Enter  
12/14/2006  
QJ